



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Gurtej S. Sandhu and Sujit Sharan

Serial No.: 09/439,314

Filed: November 12, 1999

For: DEVICE FOR IN-SITU CLEANING OF  
INDUCTIVELY-COUPLED PLASMA CHAMBERS

§  
§ Group Art Unit: 1763  
§  
§ Examiner: Thi Dang  
§  
§ Atty. Docket: 95-0392.02  
§  
§  
§

H 7B  
3/15/01  
MW

FIRST AMENDMENT AND RESPONSE TO THE  
OFFICE ACTION DATED AUGUST 30, 2000

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Certificate of Mailing (37 C.F.R. § 1.8)

I hereby certify that this correspondence is being deposited  
with the United States Postal Service as first class mail,  
postage prepaid, in an envelope addressed to:  
Commissioner for Patents, Washington, D.C. 20231, on  
the date below:

2/28/01  
Date

Charles Brannan  
Signature

Applicants herein respond to the Office Action of August 30, 2000. Please amend the  
above-captioned application as follows.

IN THE SPECIFICATION

Please change the title from "DEVICE FOR IN-SITU CLEANING OF INDUCTIVELY-  
COUPLED PLASMA CHAMBERS" to --DEVICE FOR IN-SITU CLEANING OF AN  
INDUCTIVELY-COUPLED PLASMA CHAMBER--.

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